





Applicants:

Robert B. Ogle et al.

Assignee:

Advanced Micro Devices, Inc.

Title:

Novel Oxidizing Pretreatment Of Flash ONO Nitride For Oxide

Deposition

Application No.:

10/010,280

Filing Date:

December 5, 2001

Examiner:

Marcos D. Crespo Pizarro

Group Art Unit:

2814

Docket No.:

M-7522 US

San Jose, California June 19, 2002

COMMISSIONER FOR PATENTS

Washington, D. C. 20231

## RESPONSE TO RESTRICTION REQUIREMENT

Dear Sir:

In response to the Restriction imposed by the Examiner in the above-itentified

application, Applicant elects Claims 1-16 with traverse.

**EXPRESS MAIL LABEL NO:** 

EL 937 078 816 US

Respectfully submitted,

Norman R. Klivans
Attorney for Applicants

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